## Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination | TAKAHASHI ET AL. | Examiner | Art Unit | Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,207,958	03-2001	Giakos, George C.	250/385.1
*	В	US-7,332,726	02-2008	Friedman et al.	250/374
*	O	US-6,207,958	03-2001	Giakos, George C.	250/385.1
*	D	US-5,596,201	01-1997	Charpak, Georges	250/385.1
*	Е	US-2002/0134945	09-2002	Tanimori et al.	250/385.1
	F	US-			
	O	US-			
	Ι	US-			
	ı	US-			
	٦	US-			
	K	US-	<b>1</b>		
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ζ					
	0					
	Ρ		A			
	σ					
	R					
	s					
	-			2-12-3-6	100	

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Takahashi et al., Development of a Multi-grid Type micorostrip gas chamber for synchrotron radiation applications and spallation neutron Sources, 2003, Science Direct; A 513, 201 - 205)			
	\ \				
	w				
	x				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.